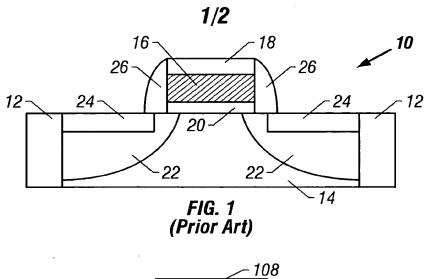
09/343,293 TRANSISTOR STRUCTURE HAVING SILICIDE SOURCE/DRAIN EXTENSIONS AND METHOD FOR MAKING SAME Peng Cheng, et al.



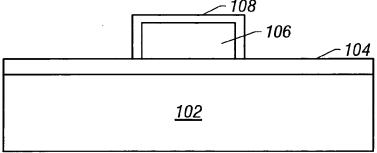


FIG. 2

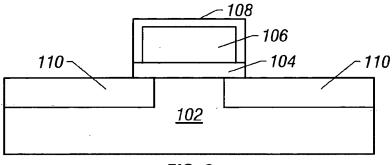


FIG. 3

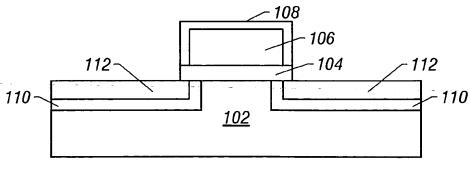


FIG. 4

2/2

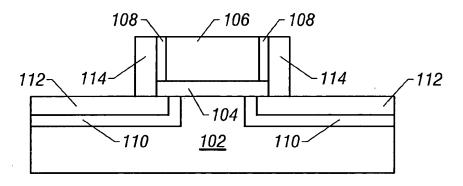
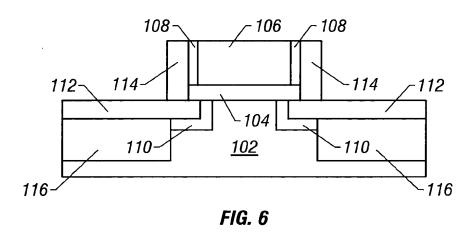


FIG. 5



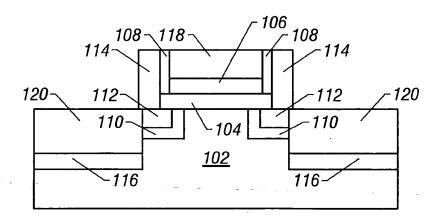


FIG. 7

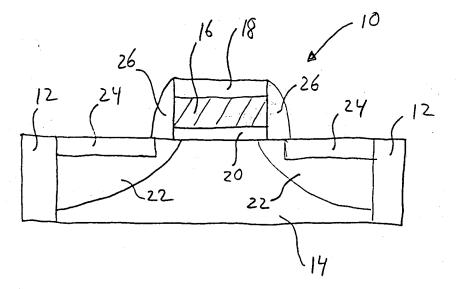


Fig. 1 (Prior Art)